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**PATENT**  
Atty Docket No. KLAC0012

I HEREBY CERTIFY THAT ON AUGUST 23, 2004, THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.

A handwritten signature in black ink, appearing to read "STEVEN W. SMYRSKI".

STEVEN W. SMYRSKI

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

CHRISTOPHER FAIRLEY, ET AL.

Title: CONFOCAL WAFER INSPECTION  
METHOD AND APPARATUS USING FLY  
LENS ARRANGEMENT

Serial No.: 09/533,203

Filed: MARCH 23, 2000

Group Art Unit: 2878

Examiner: Thanh X. Luu

**RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 21, 2004, please enter the following amendments and consider the following remarks in connection with the above-identified patent application.

**Title**

Please change the title of the application to:

Confocal Wafer Inspection Method and Apparatus Using Fly Lens Arrangement